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JC18 Rec'd PCT/PTO 20 JUL 2001

PATENT

#4
9-15-01
DRS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: ARIBERT P. WOLFRAMM ET AL-1 (PCT)
PCT NO.: PCT/DE99/04066 FILED: DECEMBER 22, 1999
FOR: METHOD FOR INTERFEROMETRIC RADAR MEASUREMENT

INFORMATION DISCLOSURE STATEMENT

BOX PCT
Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

Applicants are enclosing Form PTO-1449 disclosing the references cited in the International Search Report, copy enclosed and/or the German priority application. Since it is believed that copies of the references cited in the search report were submitted by the International Office, no copies of these references are enclosed. DE 39 22 086 is also cited in the specification on page 1, last paragraph. There are two articles cited in the specification on page 3, paragraphs 2 and 3. Since the instant Information Disclosure Statement is being filed concurrently with the application, no official fee is required in connection with the same. It is respectfully requested that the foregoing Information Disclosure Statement (IDS) be incorporated into the official file of the concurrently-filed patent application. If a fee should be required for this IDS, the Commissioner of Patents and Trademarks is hereby authorized to charge any required fee, or to credit any overpayment to Deposit Account No. 03-2468.

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Respectfully submitted,
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Enclosures: Form PTO-1449, copy of International Search Report
and four (4) references


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EXPRESS MAIL NO. **EL 769 393 487 US**

Date of Deposit: July 20, 2001

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10, on the date indicated above, and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.


Lisa L. Vulpis